Notice of References Cited Application/Control No. 10/572,589 Applicant(s)/Patent Under Reexamination YAMAUCHI ET AL. Examiner SHIN-HON CHEN Art Unit Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	Α	US-2007/0100755	05-2007	Kragt et al.	705/051
*	В	US-7,093,296	08-2006	Nusser et al.	726/26
*	С	US-2002/0120577	08-2002	Hans et al.	705/59
*	D	US-2005/0177516	08-2005	Vandewater et al.	705/057
*	Е	US-2003/0078853	04-2003	Peinado et al.	705/26
	F	US-			
	G	US-			
	Ι	US-			
	-	US-			
	7	US-			
	K	US-			
	L	US-			
	М	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	0					
	Р					
	Ø					
	R					
	Ø					
	Т					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)				
	C					
	V					
	w					
	х					

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)

Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.